

Receipt #2

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Patent application of:

Hiroto OHTAKE et al

Appln. No.: 10/080,848

Art Unit: 2814

Filed: February 22, 2002

Examiner: To be Assigned

For: **METHOD OF MANUFACTURING A
SEMICONDUCTOR DEVICE CAPABLE
OF ETCHING A MULTI-LAYER OF
ORGANIC FILMS AT A HIGH
SELECTIVITY**

Docket No.: KRM-00101

Certificate of Mailing

I hereby certify that the foregoing documents are being deposited with the United States Postal Service as first class mail, in an envelope addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231 on this date of April 19, 2002.


Name: Tracey Newell

REQUEST FOR CORRECTION OF FILING RECEIPT

Customer Corrections Branch
Assistant Commissioner for Patents
Washington, DC 20231

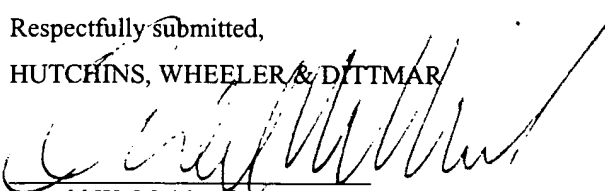
Sir:

Enclosed is a copy of the Filing Receipt for the above-identified U.S. patent application as well as a copy of the originally-filed Declaration. Please correct the number of independent claims to be 9. The change is noted in red on the copy of the Filing Receipt.

Should there be any questions concerning this request, the Examiner is invited to contact the undersigned at (617) 951-6676.

Respectfully submitted,

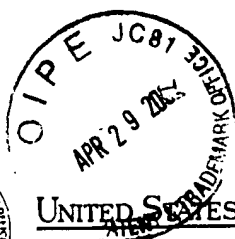
HUTCHINS, WHEELER & DITTMAR


Donald W. Muirhead
Reg. No. 33,978

April 19, 2002

Date

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APPLICATION NUMBER	FILING DATE	GRP ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLAIMS	IND CLAIMS
10/080,848	02/22/2002	2814	1490	KRM-00101	25	29	109

CONFIRMATION NO. 9662

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OC000000007852336

Date Mailed: 04/11/2002

Receipt is acknowledged of this nonprovisional Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Customer Service Center. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

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Assignment For Published Patent Application

NEC Corporation;

Domestic Priority data as claimed by applicant

Foreign Applications

JAPAN 047358/2001 02/22/2001

If Required, Foreign Filing License Granted 03/19/2002

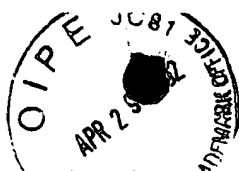
Projected Publication Date: 08/22/2002

Non-Publication Request: No

Early Publication Request: No

Title

Method of manufacturing a semiconductor device capable of etching a multi-layer of organic films at a high selectivity



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Preliminary Class

257

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